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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Akihiko OTOGURO et al.

Group Art Unit: 2822

Serial No.: 10/603,077

Examiner: Christy L. Novacek

Filed: June 25, 2003

Confirmation No.: 1877

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND

METHOD OF FORMING PATTERN

Attorney Docket Number: 030757

Customer Number: 38834

PETITION FOR WITHDRAWAL FROM ISSUE UNDER 37 CFR §1.313(c)(2)

OFFICE OF PETITIONS

Mail Stop 313(c)

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Date: July 27, 2005

Sir:

It is respectfully requested that the present application be withdrawn from issue for consideration of a Request for Continued Examination and the attached submission of an Information Disclosure Statement.

A Request for Continued Examination and an Information Disclosure Statement are submitted concurrently herewith.

Attached is a check in the amount of \$130.00 to cover the fee for filing this Petition.

In the event this paper is not considered to be timely filed, the Applicants hereby petition for an appropriate extension of the response period. Please charge the fee for such extension and any other fees which may be required to our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

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Registration No. 56,171 Telephone: (202) 822-1100

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Attachments: Request for Continued Examination (RCE) with check \$790.00

Information Disclosure Statement (IDS)